



APW ✓

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re Application of:**

D. Wang

**Serial No.:** 10/729,112

**Filed:** December 5, 2003

**For:** DEFORMABLE PAD FOR  
CHEMICAL MECHANICAL POLISHING

**Confirmation No.:** 3169

**Examiner:** R. Rose

**Group Art Unit:** 3723

**Attorney Docket No.:** 2269-3579.2US  
(98-0062.02/US)

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

March 3, 2005  
Date

Signature

Joseph A. Walkowski  
Name (Type/Print)

**AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Office Action mailed December 3, 2004, the three-month shortened statutory period for response to which expires on March 3, 2005.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 8 of this paper.

03/09/2005 WASFAW1 00000012 10729112

01 FC:1201 1400.00 OP  
02 FC:1202 150.00 OP